



Atomic Layer Deposition Systems and Methods
Thomas R. Omstead; Karl B. Levy
M-11953 US

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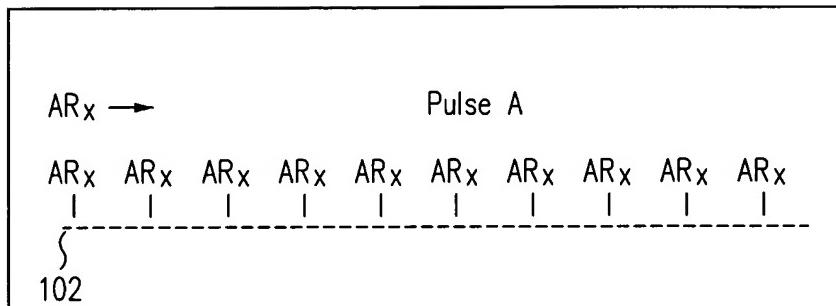


FIG. 1
(PRIOR ART)

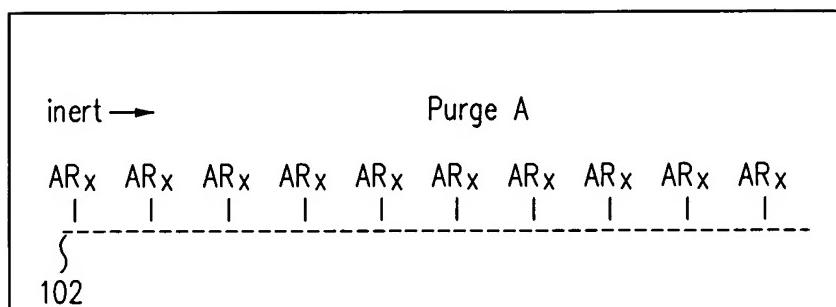


FIG. 2
(PRIOR ART)

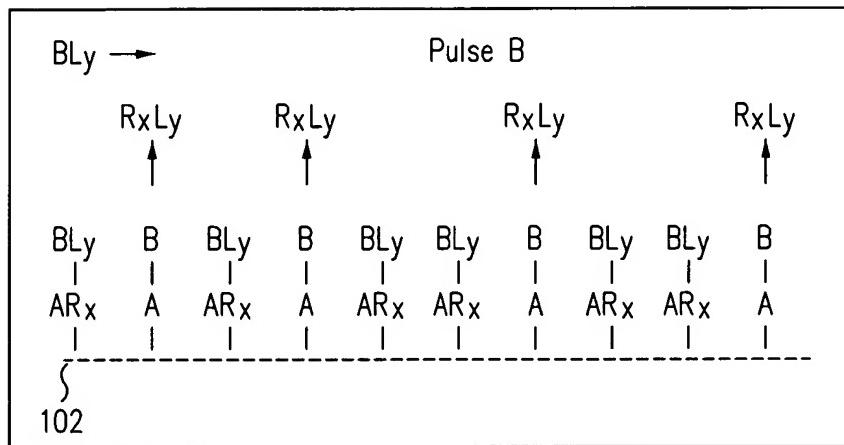


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300 FIG. 3
(PRIOR ART)

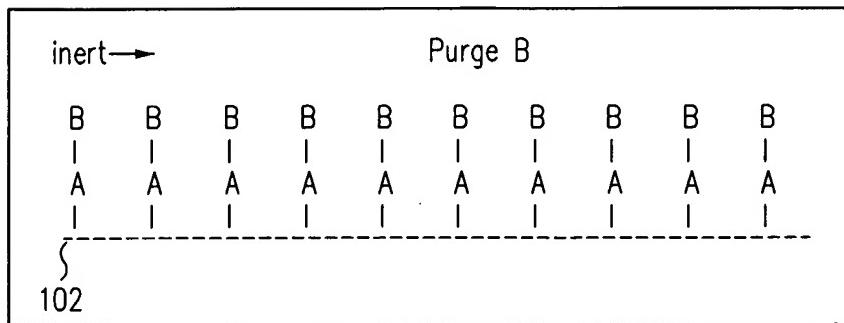


FIG. 4
(PRIOR ART)



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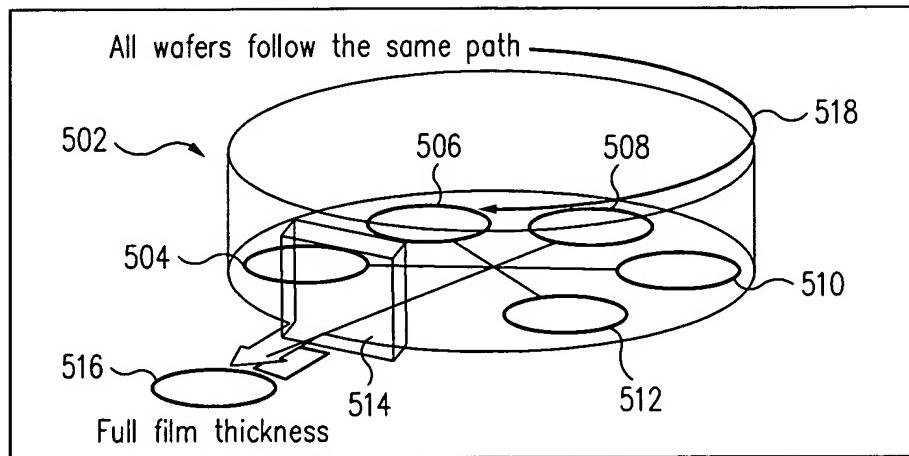


FIG. 5

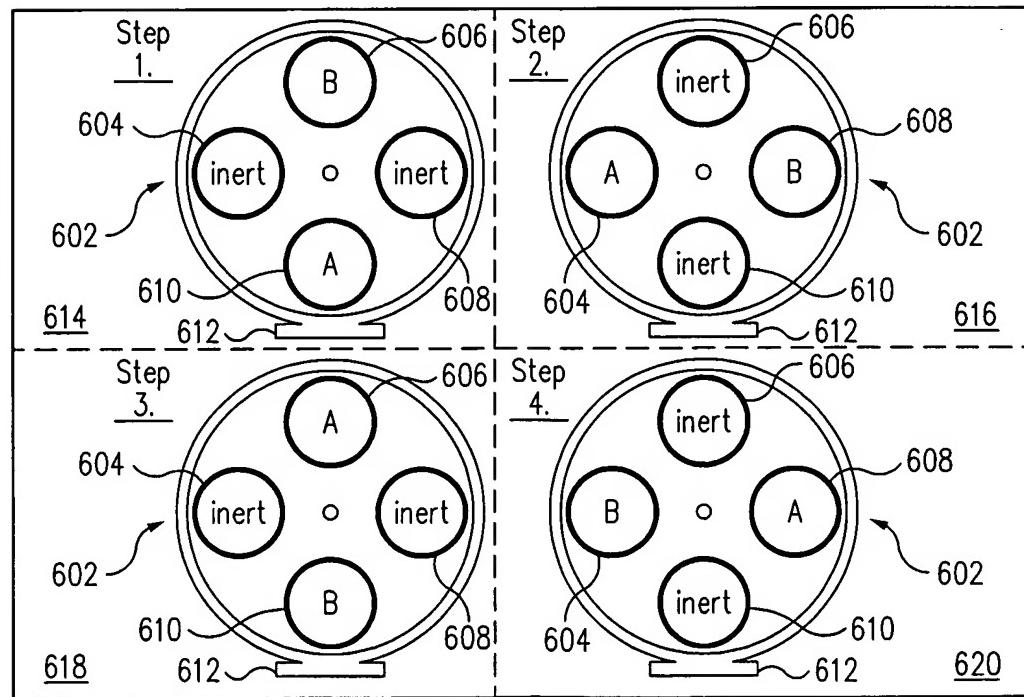


FIG. 6



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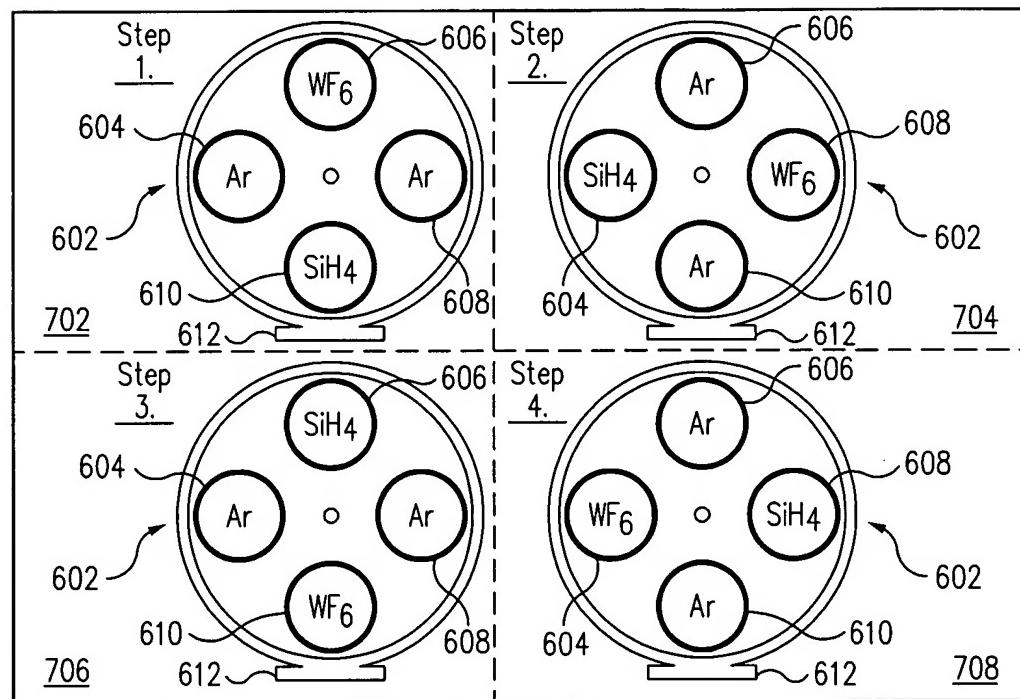


FIG. 7

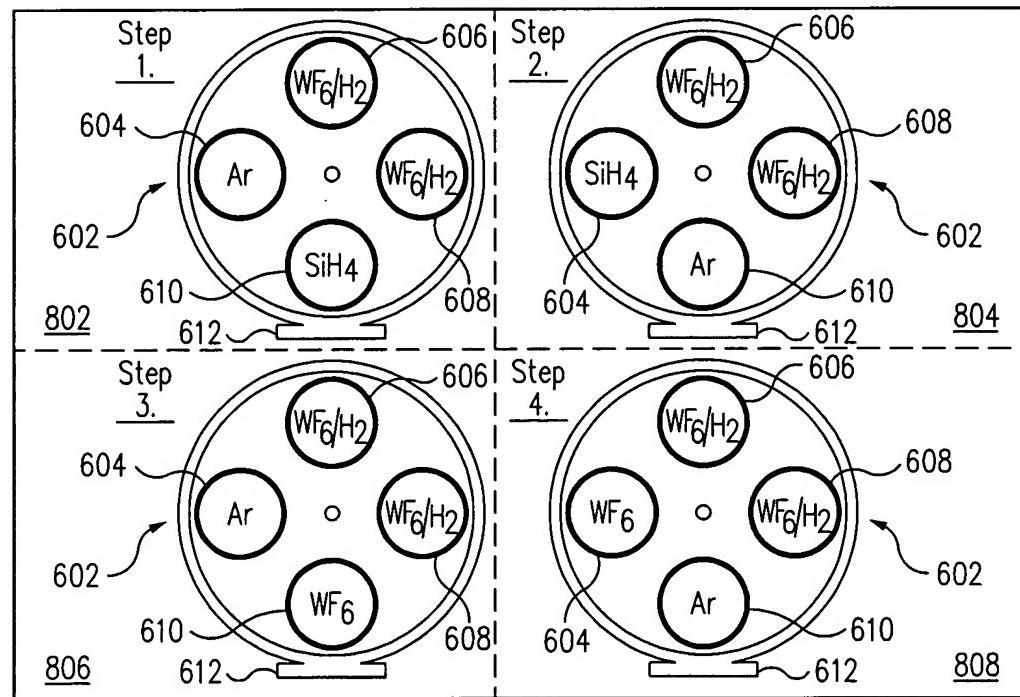


FIG. 8



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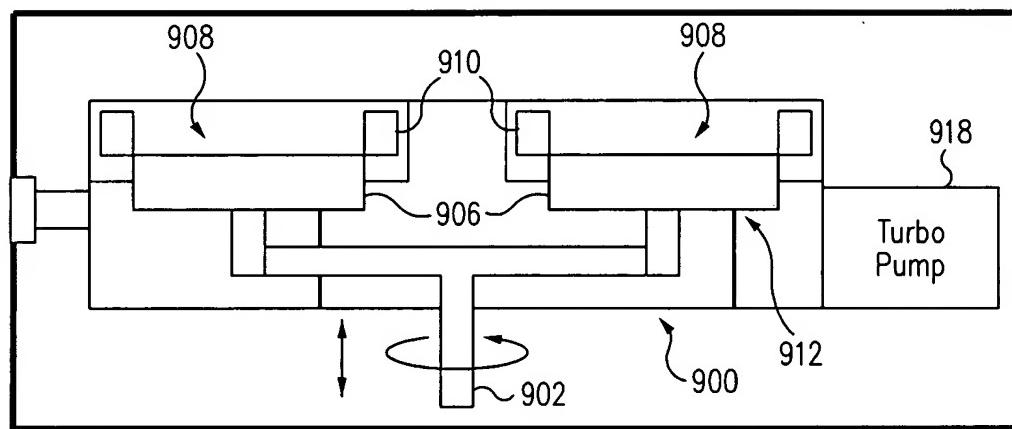


FIG. 9



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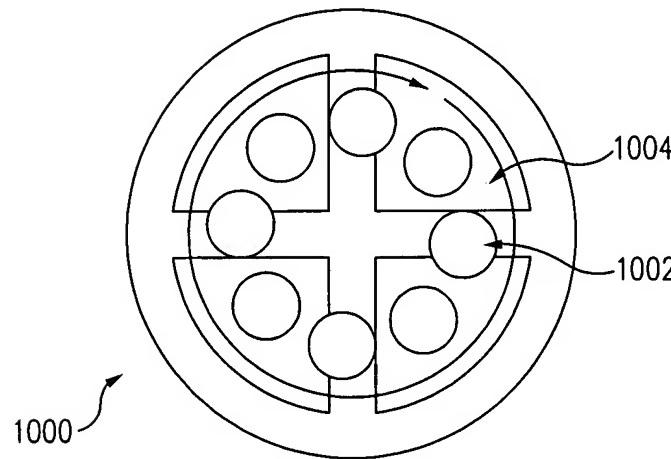


FIG. 10

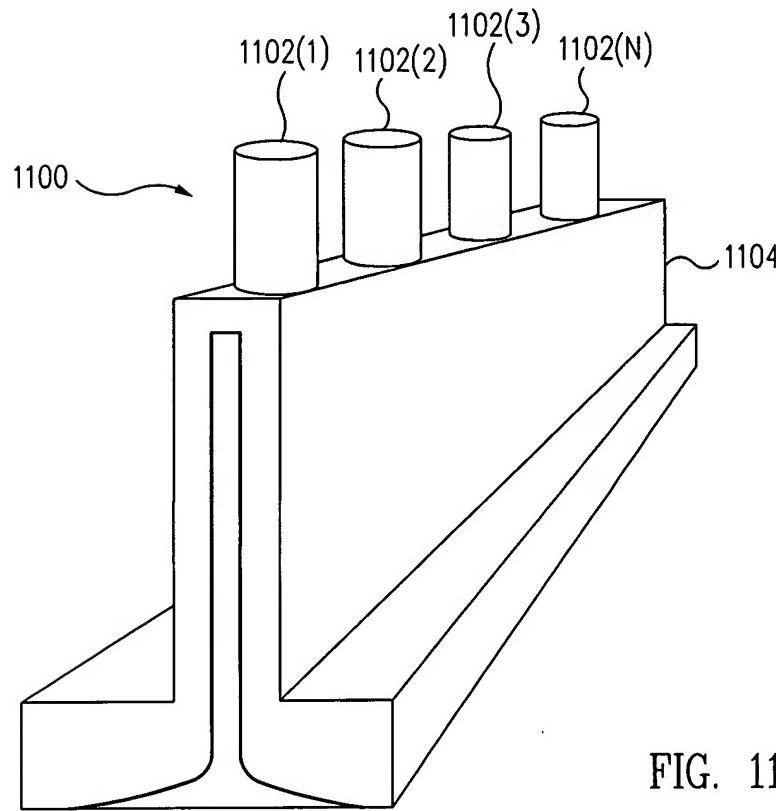


FIG. 11



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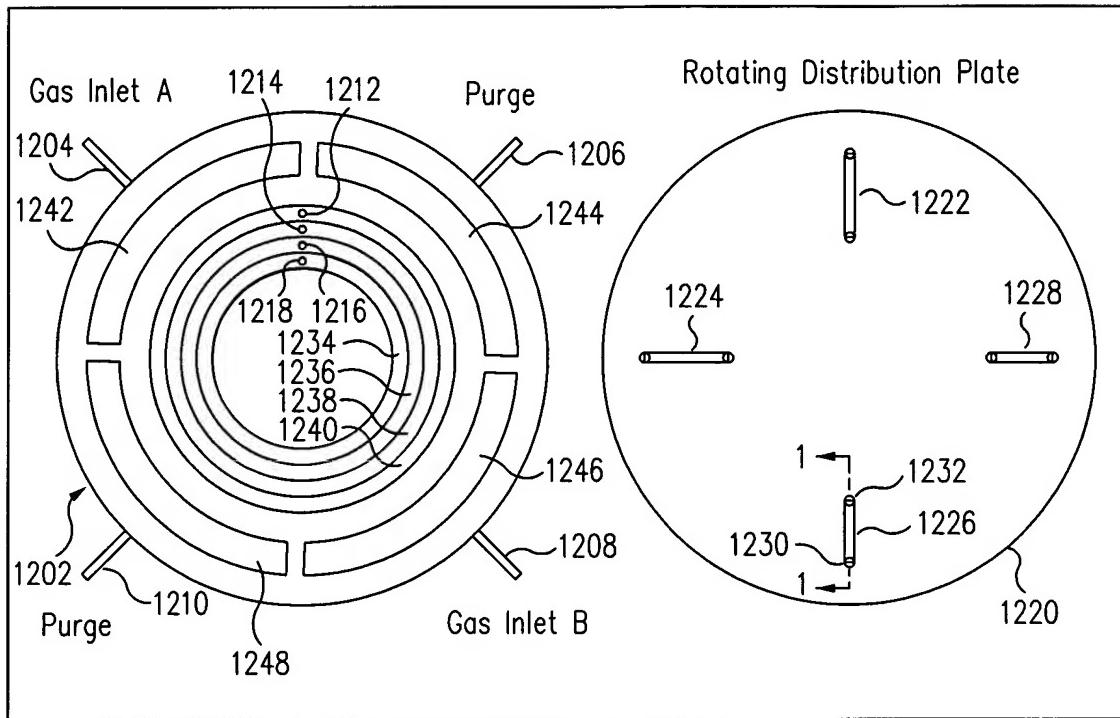


FIG. 12

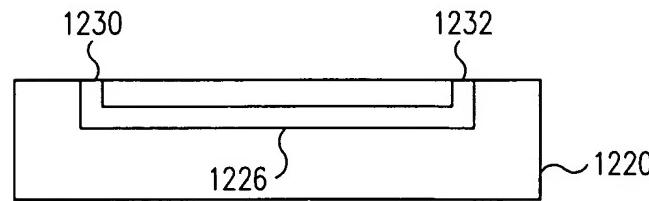


FIG. 13